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September 2, 2003

MAIL STOP PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Application of Kunio KAWAKAMI, Osamu KOSHIISHI, Kazuo TANAKA,
Osamu HANAMURA
SHIELDING DEVICE FOR ANTENNA BOARD, AND LIQUID EJECTION
APPARATUS INCORPORATING THE SAME
Assignee: SEIKO EPSON CORPORATION
Our Ref. Q77254

17497 U.S. PTO
10/652240
09/02/03

Dear Sir:

Attached hereto is the application identified above comprising 31 sheets of the specification (Japanese Language), including the claims and abstract and 29 sheets of drawings. **The requisite U.S. Government Filing Fee, verified English Translation, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.** Also enclosed is an Information Disclosure Statement and PTO/SB/08 A & B (modified).

The Government filing fee is calculated as follows:

Total claims	10 - 20	=		x	\$18.00	=	\$0.00
Independent claims	1 - 3	=		x	\$84.00	=	\$0.00
Base Fee							\$750.00

TOTAL FEE

\$750.00


Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	2002-252599	August 30, 2002
Japan	2003-306009	August 29, 2003

The priority documents will be filed at a later date.

Respectfully submitted,
SUGHRUE MION, PLLC
Attorneys for Applicant

By:


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